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## BIB DATA SHEET

CONFIRMATION NO. 7353

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.		
10/559,135	02/11/2008	451	3723	2005-1890A		
<b>RULE</b>						
<b>APPLICANTS</b> Tetsuji Togawa, Tokyo, JAPAN; Koichi Fukaya, Tokyo, JAPAN; Mitsuo Tada, Tokyo, JAPAN; Taro Takahashi, Tokyo, JAPAN; Yasunari Suto, Tokyo, JAPAN;						
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP2004/008855 06/17/2004						
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2003174144 06/18/2003						
<b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 03/03/2008						
Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No		JAPAN	23	18	6
Verified and Acknowledged	/EILEEN P MORGAN/ Examiner's Signature	Initials				
<b>ADDRESS</b> WENDEROTH, LIND & PONACK, L.L.P. 1030 15th Street, N.W., Suite 400 East Washington, DC 20005-1503 UNITED STATES						
<b>TITLE</b> Substrate Polishing Apparatus And Substrate Polishing Method						
<b>FILING FEE RECEIVED</b> 1650	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees		
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